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ATTY. DOCKET NO.

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900-411

10/041,681

YAMAMOTO et al

FENGDATE

## GROUP

January 10, 2002

1753

## U.S. PATENT DOCUMENTS

## **FOREIGN PATENT DOCUMENTS**

**OTHER DOCUMENTS (including Author, Title, Date, Pertinent pages, etc.)**

ADD	"Effects of Substrates with Different Surface Morphology on Microcrystalline Silicon Solar Cells", Nasuno et al., page 829, 6a-C-6, 9-2000.
ADD	"Effects of Substrates with Different Surface Morphology on Microcrystalline Silicon Solar Cells", Nasuno et al., April 2001, pages L-303-L305
ADD	"Microcrystalline Silicon Thin-Film Solar Cells Prepared at Low Temperature Using PECVD", Nasuno et al., Korea, 2001, pages 791-794
ADD	"Microcrystalline Silicon Thin-Film Solar Cells Prepared at Low Temperature Using RF-PECVD", Nasuno et al., Sept. 2000
ADD	"Microcrystalline Silicon Thin-Film Solar Cells Prepared at Low Temperature", Nasuno et al., 2001, pages A15.5.1-12

\*Examiner

1-12  
also

**Date Considered**

8/14/03

Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to application.

Form PTO-FB-A820 (Also PTO-1449)